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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

FUKUDA, Masatoshi et al.

Group Art Unit: **2815**

Serial No.: **10/020,951**

Examiner: **LANDAU, Matthew C.**

Filed: **December 19, 2001**

P.T.O. Confirmation No.: **8648**

For: **SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME**

Attorney Docket No.: **011724**

Customer No.: **38834**

AMENDMENT UNDER 37 CFR § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 13, 2004

Sir:

In response to the Office Action dated April 14, 2004, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.